



PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ma, et al.

Application No.: 09/374,502

Confirmation No.: 3832

Filed: August 13, 1999

For: Isolation Structure Configurations for  
Modifying Stresses in Semiconductor  
Devices

Examiner: Jesse Fenty

Group Art Unit: 2815

Attorney Docket No.: 42390.P6623

## CERTIFICATE OF MAILING

I hereby certify that this paper or fee along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail (under 37 C.F.R. § 1.8(a)) on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner of Patents and Trademarks, Washington, D.C. 20231.

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RESPONSE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 4, 2003, please amend the above-  
identified application as follows:

Remarks/Arguments begin on page 2 of this paper.